

## Electronic Patent Application Fee Transmittal

Application Number:	09925579			
Filing Date:	09-Aug-2001			
Title of Invention:	Plasma processing apparatus and system, performance validation system and inspection method therefor			
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Filer:	Gustavo Siller Jr./Marianne Hall			
Attorney Docket Number:	9281-4140			
Filed as Large Entity				
<b>Utility Filing Fees</b>				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
Post-Allowance-and-Post-Issuance:				
<b>Extension-of-Time:</b>				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Submission- Information Disclosure Stmt	1806	1	180	180
<b>Total in USD (\$)</b>				<b>180</b>